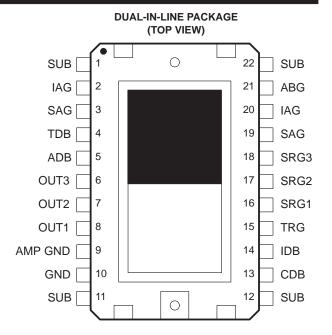
- High-Resolution, Solid-State Image Sensor for NTSC B/W TV Applications
- 11-mm Image-Area Diagonal, Compatible With 2/3" Vidicon Optics
- 754 (H) x 244 (V) Active Elements in Image-Sensing Area
- Low Dark Current
- Electron-Hole Recombination Antiblooming
- Dynamic Range . . . More Than 60 dB
- High Sensitivity
- High Photoresponse Uniformity
- High Blue Response
- Single-Phase Clocking
- Solid-State Reliability With No Image Burn-in, Residual Imaging, Image Distortion, Image Lag, or Microphonics



description

The TC241 is a frame-transfer charge-coupled device (CCD) image sensor designed for use in single-chip B/W NTSC TV applications. The device is intended to replace a 2/3-inch vidicon tube in applications requiring small size, high reliability, and low cost.

The image-sensing area of the TC241 is configured into 244 lines with 780 elements in each line. Twenty-four elements are provided in each line for dark reference. The blooming-protection feature of the sensor is based on recombining excess charge with charge of opposite polarity in the substrate. This antiblooming is activated by supplying clocking pulses to the antiblooming gate, which is an integral part of each image-sensing element.

The sensor is designed to operate in an interlace mode, electronically displacing the image-sensing elements by one-half of a vertical line during the charge integration period in alternate fields, effectively increasing the vertical resolution and minimizing aliasing. The device can also be run as a 754 (H) by 244 (V) noninterlaced sensor with significant reduction in the dark signal.

A gated floating-diffusion detection structure with an automatic reset and voltage reference incorporated on-chip converts charge to signal voltage. A low-noise, two-stage, source-follower amplifier buffers the output and provides high output-drive capability.

The TC241 is built using TI-proprietary virtual-phase technology, which provides devices with high blue response, low dark current, high photoresponse uniformity, and single-phase clocking.

The TC241 is characterized for operation from -10°C to 45°C.

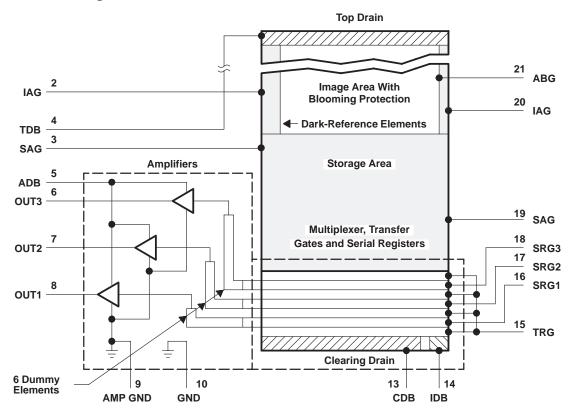


This MOS device contains limited built-in gate protection. During storage or handling, the device leads should be shorted together or the device should be placed in conductive foam. In a circuit, unused inputs should always be connected to SUB. Under no circumstances should pin voltages exceed absolute maximum ratings. Avoid shorting OUTn to ADB during operation to prevent damage to the amplifier. The device can also be damaged if the output terminals are reverse-biased and an excessive current is

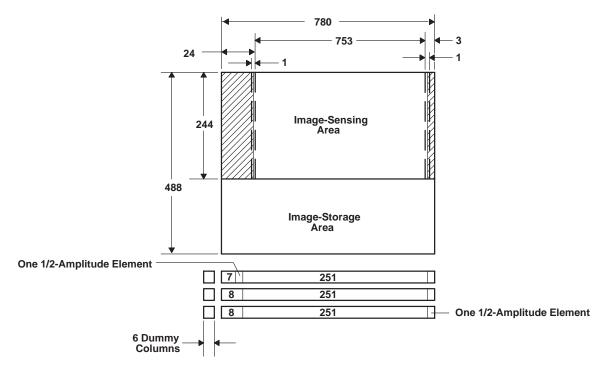
allowed to flow. Specific guidelines for handling devices of this type are contained in the publication *Guidelines for Handling Electrostatic-Discharge-Sensitive (ESDS) Devices and Assemblies* available from Texas Instruments.



functional block diagram



sensor topology diagram



Terminal Functions

TERMINAL		1/0	DESCRIPTION		
NAME	NO.	1/0	DESCRIPTION		
ABG	21	I	Antiblooming gate		
ADB	5	I	Supply voltage for amplifier-drain bias		
AMP GND	9		Amplifier ground		
CDB	13	Ι	Supply voltage for clearing-drain bias		
GND	10		Ground		
IAG†	2	1	Image-area gate		
IAG†	20	I	Image-area gate		
IDB	14	I	Supply voltage for input diode bias		
OUT1	8	0	Output signal 1		
OUT2	7	0	Output signal 2		
OUT3	6	0	Output signal 3		
SAG†	3	I	Storage-area gate		
SAG†	19	I	Storage-area gate		
SRG1	16	I	Serial-register gate 1		
SRG2	17	I	Serial-register gate 2		
SRG3	18	I	Serial-register gate 3		
SUB [†]	1		Substrate and clock return		
SUB†	11		Substrate and clock return		
SUB†	12		Substrate and clock return		
SUB [†]	22		Substrate and clock return		
TDB	4	I	Supply voltage for top-drain bias		
TRG	15	I	Transfer gate		

 $[\]dagger$ All pins of the same name should be connected together externally.



detailed description

The TC241 consists of four basic functional blocks: (1) the image-sensing area, (2) the image-storage area, (3) the multiplexer with serial registers and transfer gates, and (4) the buffer amplifier with charge-detection nodes. The location of each of these blocks is shown in the functional block diagram.

image-sensing storage areas

Cross sections with potential-well diagrams and top views of image-sensing and storage-area elements are shown in Figure 1 and Figure 2. As light enters the silicon in the image-sensing area, free electrons are generated and collected in the potential wells of the sensing elements. During this time, the antiblooming gate is activated by the application of a burst of pulses every horizontal-blanking interval. This prevents blooming caused by the spilling of charge from overexposed elements into neighboring elements. After the completion of integration, the signal charge is transferred into the storage area. To generate the dark reference necessary in subsequent video-processing circuits for restoration of the video-black level, 23 full columns and one half-column of elements at the left edge of the image-sensing area are shielded from incident light. Two full columns and one half-column of elements at the right of the image-sensing area are also shielded from incident light. The total number of elements per row is 780 (753 active elements plus 25 shielded elements and 2 transitional elements).

multiplexer with transfer gates and serial registers

The multiplexer and transfer-gates transfer charge line by line from the image-element columns into the corresponding serial register and prepare it for readout. Multiplexing is activated during the horizontal-blanking interval by applying appropriate pulses to the transfer gates and serial registers. The required pulse timing is shown in Figure 3. A drain is included in this area to provide the capability to quickly clear the image-sensing and storage areas of unwanted charge. Such charge can accumulate in the imager during the start-up of operation or under special circumstances when nonstandard TV operation is desired.

buffer amplifier with charge-detection nodes

The buffer amplifier converts charge into a video signal. Figure 4 shows the circuit diagram of a charge-detection node and one of the three amplifiers. As charge is transferred into the detection node, the potential of this node changes in proportion to the amount of signal received. This change is sensed by an MOS transistor and, after proper buffering, the signal is supplied to the output terminal of the image sensor. After the potential change has been sensed, the node is reset to a reference voltage supplied by an on-chip reference generator. The reset is accomplished by a reset gate that is connected internally to the serial register. The detection nodes and corresponding amplifiers are located some distance from the edge of the storage area; six dummy elements are used to span this distance. The location of the dummy elements is shown in the functional block diagram.

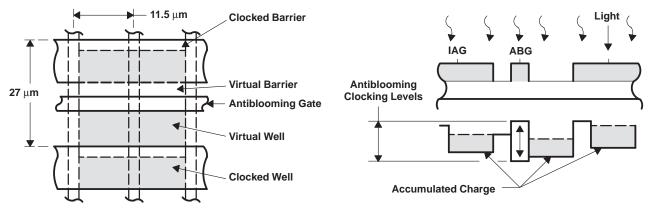


Figure 1. Charge-Accumulation Process



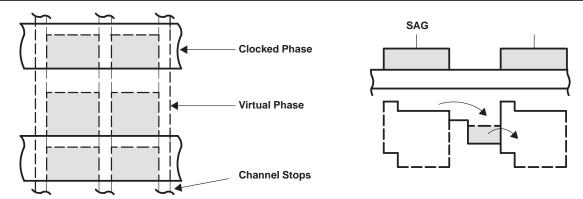


Figure 2. Charge-Transfer Process

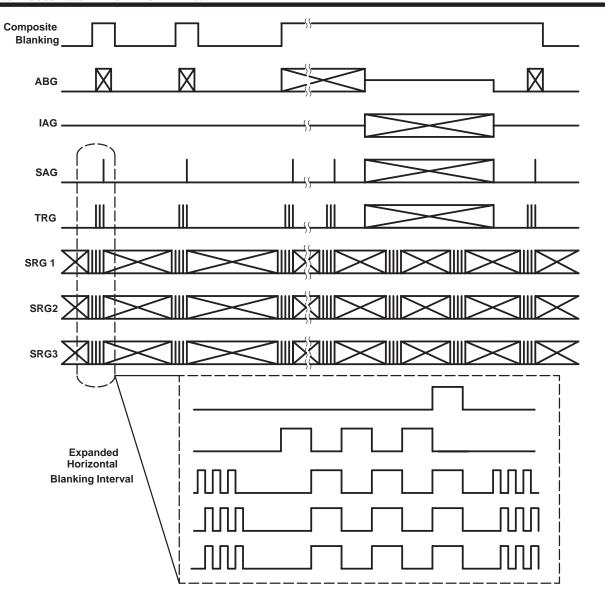


Figure 3. Timing Diagram

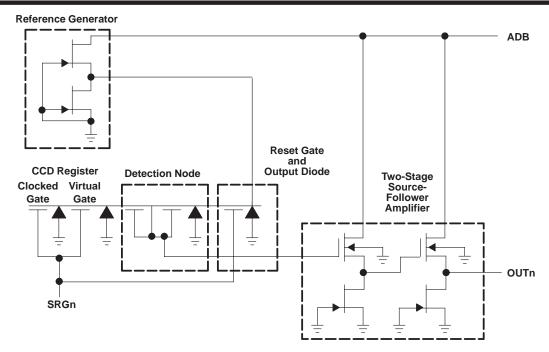


Figure 4. Buffer Amplifier and Charge-Detection Node

spurious-nonuniformity specification

The spurious-nonuniformity specification of the TC241 CCD grades -10, -20, -30, and -40 is based on several sensor characteristics:

- Amplitude of the nonuniform pixel
- Polarity of the nonuniform pixel
 - Black
 - White
- Location of the nonuniformity (see Figure 5)
 - Area A
 - Element columns near horizontal center of the area
 - Element rows near vertical center of the area
 - Area B
 - Up to the pixel or line border
 - Up to area A
 - Other
 - Edge of the imager
 - Up to area B
- Nonuniform pixel count
- Distance between nonuniform pixels
- Column amplitude

The CCD sensors are characterized in both an illuminated condition and a dark condition. In the dark condition, the nonuniformity is specified in terms of absolute amplitude as shown in Figure 6. In the illuminated condition, the nonuniformity is specified as a percentage of the total illumination as shown in Figure 7.

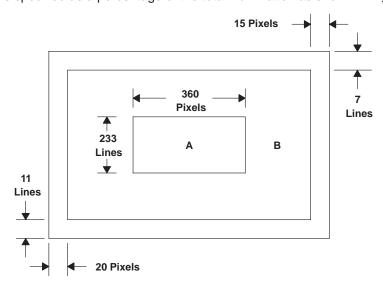


Figure 5. Sensor-Area Map



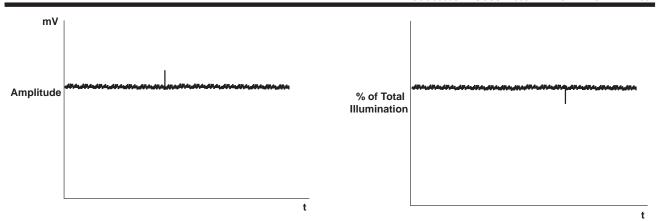


Figure 6. Pixel-Nonuniformity, Dark Condition

Figure 7. Pixel-Nonuniformity, **Illuminated Condition**

The grade specification for the TC241 is as follows (CCD video-output signal is 50 mV ±10 mV): Pixel-nonuniformity:

	DARK CONDITION ILLUMINATED CONDITION				TION	DISTANC		ICE						
		NONUNIFORM P			/I PIX	XEL TYPE						SEPARATION		
PART NUMBER	PIXEL AMPLITUDE, x	WH	ITE	BLA	ACK	W/	в†			AREA B	TOTAL COUNT‡			
I NOMBER	(mV) AREA AREA AREA ILLUMINATION AREA A	ANEA B		x	Y	AREA								
		Α	В	Α	В	Α	В							
TC241-20	x > 3.5	0	0	0	0	0	0	x > 5	0	0	_			_
TC241-30	2.5 < x ≤ 3.5	2	5	2	5	2	5	$5.0 < x \le 7.5$	2	5	12	100	80	Α
10241-30	x > 3.5	0	0	0	0	0	0	x > 7.5	0	0	12	100	00	
TC241-40	3.5 < x ≤ 7	3	7	3	7	3	7	7.5 < x ≤ 15	3	7	15			
10241-40	x > 7	0	0	0	0	0	0	x > 15	0	0	15			

[†] White and black nonuniform pixel pair

Column nonuniformity:

PART	COLUMN	WHITE	BLACK	
NUMBER	AMPLITUDE, x (mV)	AREAS A AND B	AREAS A AND B	
TC241-20	x > 0.3	0	0	
TC241-30	x > 0.5	0	0	
TC241-40	x > 0.7	0	0	

[‡] The total spot count is the sum of all nonuniform white, black, and white/black pairs in the dark condition added to the number of nonuniform black pixels in the illuminated condition. The sum of all nonuniform combinations do not exceed the total count.

$780- \times 488$ -PIXEL CCD IMAGE SENSOR

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absolute maximum ratings over operating free-air temperature range (unless otherwise noted)†

Supply voltage range, V _{CC} : ADB, CDB, IDB, TDB (see Note 1)	0 V to 15 V
Input voltage range, V _I : ABG, IAG, SAG, SRG, TRG	–15 V to 15 V
Operating free-air temperature range, T _A	−10°C to 45°C
Storage temperature range, T _{STG}	-30°C to 85°C
Lead temperature 1,6 mm (1/16 inch) from case for 10 seconds	260°C

[†] Stresses beyond those listed under "absolute maximum ratings" may cause permanent damage to the device. These are stress ratings only and functional operation of the device at these or any other conditions beyond those indicated under "recommended operating conditions" is not implied. Exposure to absolute-maximum-rated conditions for extended periods may affect device reliability.

recommended operating conditions

			MIN	NOM	MAX	UNIT	
Supply voltage, V _{CC}	ADB, CDB, IDB, TDB	11	12	13	V		
Substrate bias voltage				0		V	
		High level	1.5	2	2.5		
	IAG	Intermediate level§		-5			
		Low level	-10	-9	-8		
	SBC4 SBC2 SBC2	High level	1.5	2	2.5	v	
	SRG1, SRG2, SRG3	Low level	-10	-9	-8		
Innut voltage \/\tau	ABG	High level	2	4	6		
Input voltage, V _I ‡		Intermediate level§		-2.5		ľ	
		Low level		-7			
	SAG	High level	1.5	2	2.5		
		Low level	-10	-9	-8		
	TRG	High level	1.5	2	2.5		
	ING	Low level	-10	-9	-8		
	IAG, SAG				2.05		
Clock frequency, f _{clock}	SRG1, SRG2, SRG3, TRG				4.77	MHz	
	ABG				2.05]	
Load capacitance	OUT1, OUT2, OUT3			8	pF		
Operating free-air temper	Operating free-air temperature, T _A				45	°C	

The algebraic convention, in which the least-positive (most negative) value is designated minimum, is used in this data sheet for clock voltage levels.



NOTE 1: All voltage values are with respect to the substrate terminal.

 $[\]S$ Adjustment is required for optimal performance.

electrical characteristics over recommended operating ranges of supply voltage and operating free-air temperature (unless otherwise noted)

	MIN	TYP	MAX	UNIT	
Dynamic range (see Note 2)	Antiblooming disabled (see Note 3)	60			dB
Charge-conversion factor	·	1.4	1.6	1.8	μV/e
Charge-transfer efficiency (see Note 4)		0.9999	0.99995		
Signal-response delay time, τ (see Note	5 and Figure 11)	18	20	22	ns
Gamma (see Note 6)		0.97	0.98		
Output resistance			700	800	Ω
Naine veltage	1/f noise (5 kHz)		0.13		\//\/\
Noise voltage	Random noise (f = 100 kHz)		0.11		μV/√Hz
Noise-equivalent signal			120		electrons
	ADB (see Note 7)		20		
Rejection ratio at 4.77 MHz	SRG1, SRG2, SRG3 (see Note 8)		40		dB
	ABG (see Note 9)		20		
Supply current			5		mA
	IAG		12000		
	SRG1, SRG2, SRG3		120		
Input capacitance, C _i	ABG		4000		pF
	TRG		350		
	SAG		14000		

[†] All typical values are at $T_A = 25$ °C

NOTES: 2. Dynamic range is -20 times the logarithm of the mean-noise signal divided by the saturation-output signal.

- 3. For this test, the antiblooming gate must be biased at the intermediate level.
- 4. Charge-transfer efficiency is one minus the charge loss per transfer in the output register. The test is performed in the dark using an electrical input signal.
- 5. Signal-response delay time is the time between the falling edge of the SRG clock pulse and the output-signal valid state.
- 6. Gamma (γ) is the value of the exponent in the equation below for two points on the linear portion of the transfer-function curve (this value represents points near saturation):

$$\left(\frac{\mathsf{Exposure} \ \, (2)}{\mathsf{Exposure} \ \, (1)} \right)^{\gamma} \ \, = \ \, \left(\frac{\mathsf{Output} \ \, \mathsf{signal} \ \, (2)}{\mathsf{Output} \ \, \mathsf{signal} \ \, (1)} \right)$$

- 7. ADB rejection ratio is -20 times the logarithm of the ac amplitude at the output divided by the ac amplitude at ADB.
- 8. SRGn rejection ratio is -20 times the logarithm of the ac amplitude at the output divided by the ac amplitude at SRGn.
- 9. ABG rejection ratio is -20 times the logarithm of the ac amplitude at the output divided by the ac amplitude at ABG.

780- × 488-PIXEL CCD IMAGE SENSOR

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optical characteristics, $T_A = 40^{\circ}C$ (unless otherwise noted)

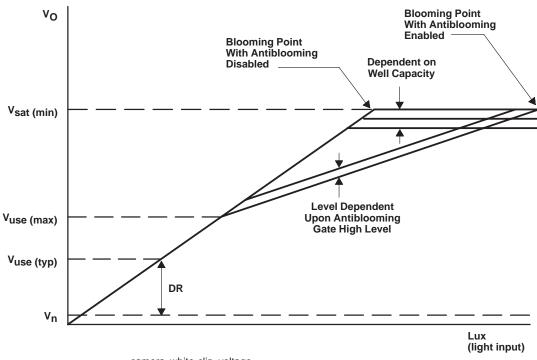
	PARAMETER		MIN	TYP	MAX	UNIT
Concitivity	No IR filter	Measured at Vu		150		ma\ / /lax
Sensitivity	With IR filter	(see Notes 10 and 11)		19		mV/lx
Saturation signal, V _{Sat} (see Note 12)	Antiblooming disabled, interlace	off	320	400		mV
Maximum usable signal, V _{use}	Antiblooming enabled, interlace	on	180	360		mV
Diamina and add (as Nata 40)	•	Interlace on	100			
Blooming-overload ratio (see Note 13)		Interlace off	200			1
Image-area well capacity	•		200 x 10 ³		electrons	
Smear (see Note 14)		See Note 15		0.00072		
Dark current	Interlace off	T _A = 21°C		0.027		nA/cm ²
Dowle signal (see Note 46)	•	TC241-30			15	\/
Dark signal (see Note 16)		TC241-40			20	m∨
Divel and the second	Output size of 50 m/ 140 m/	TC241-30			3.5	\/
Pixel uniformity	Output signal = 50 mV ±10 mV	TC241-40			5	m∨
Column uniformity	Output signal 50 m)/ 140 m)/	TC241-30			0.5	\/
Column uniformity	Output signal = 50 mV ±10 mV	TC241-40			0.7	m∨
Shading	Output signal = 100 mV				15%	

NOTES: 10. Sensitivity is measured at an integration time of 16.667 ms with a source temperature of 2856 K. A CM-500 filter is used.

- 11. V_U is the output voltage that represents the threshold of operation of antiblooming. $V_U \approx 1/2$ saturation signal.
- 12. Saturation is the condition in which further increase in exposure does not lead to further increase in output signal.
- 13. Blooming-overload ratio is the ratio of blooming exposure to saturation exposure.
- 14. Smear is a measure of the error induced by transferring charge through an illuminated pixel in shutterless operation. It is equivalent to the ratio of the single-pixel transfer time during a fast dump to the exposure time using an illuminated section that is 1/10 of the image-area vertical height with recommended clock frequencies.
- 15. Exposure time is 16.67 ms and the fast-dump clocking rate during vertical timing is 2.05 MHz.
- 16. Dark-signal level is measured from the dummy pixels.



PARAMETER MEASUREMENT INFORMATION



 $DR (dynamic range) = \frac{camera \ white-clip \ voltage}{V_n}$

 V_n = noise-floor voltage

V_{sat (min)} = minimum saturation voltage

V_{use (max)} = maximum usable voltage

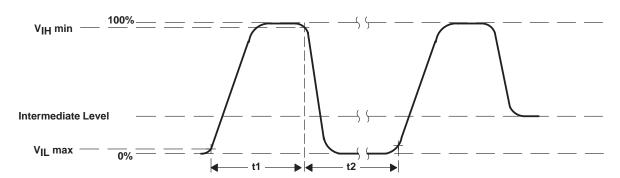
V_{use} (typ) = typical user voltage (camera white clip)

NOTES: A. V_{use (typ)} is defined as the voltage determined to equal the camera white clip. This voltage must be less than V_{use} (max).

B. A system trade-off is necessary to determine the system light sensitivity versus the signal/noise ratio. By lowering the V_{use} (typ), the light sensitivity of the camera is increased; however, this sacrifices the signal/noise ratio of the camera.

Figure 8. Typical V_{sat}, V_{use} Relationship

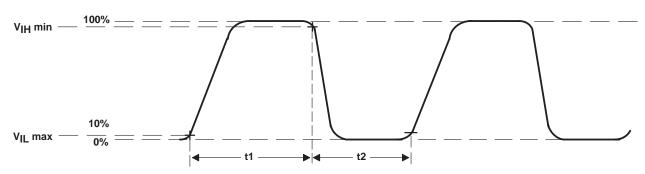
PARAMETER MEASUREMENT INFORMATION



Slew rate between 10% and 90% = 70 to 120 $V/\mu s$

Ratio t1 : t2 at 2 MHz = 4:3 Ratio t1 : t2 at 1 MHz = 1:1

Figure 9. Typical Clock Waveform for ABG, IAG, and SAG



Slew rate between 10% and 90% = 300 V/ μ s Ratio t1 : t2 = 1:1

Figure 10. Typical Clock Waveform for SRG1, SRG2, SRG3, and TRG

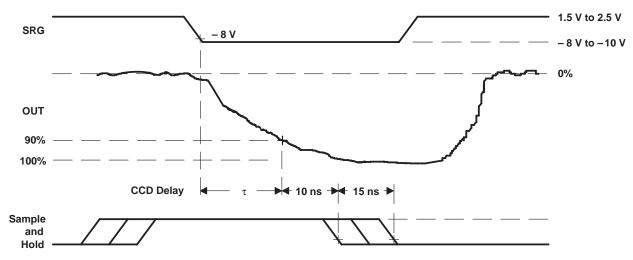


Figure 11. SRG and CCD Output Waveforms



TYPICAL CHARACTERISTICS

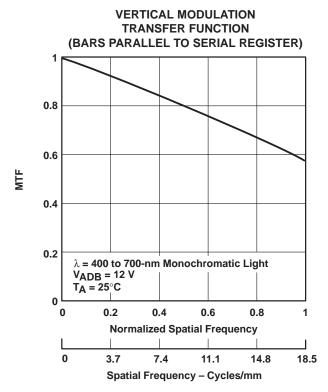


Figure 12

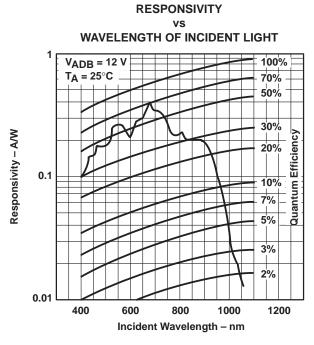


Figure 14

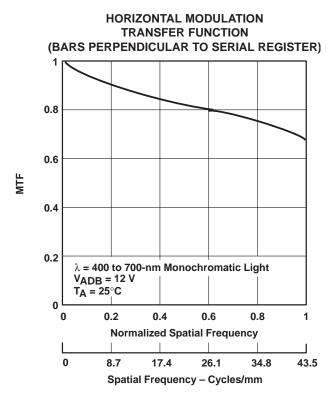
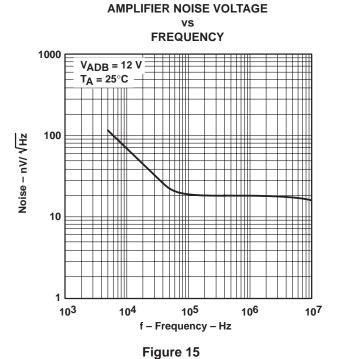
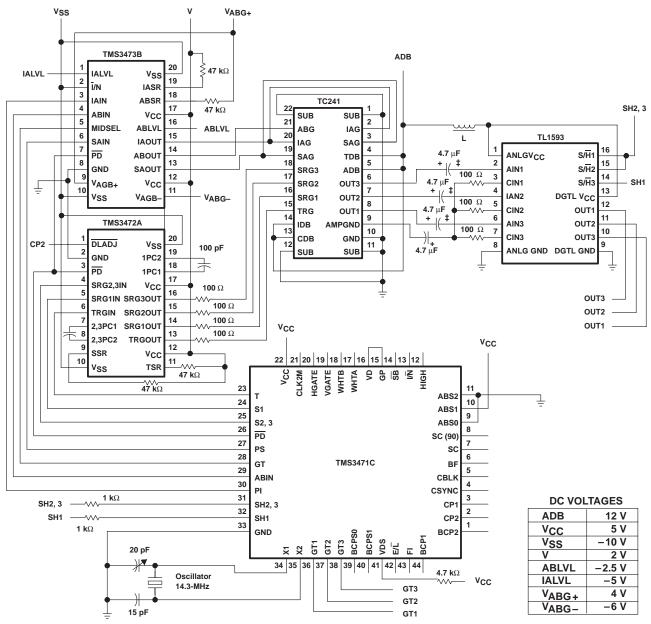


Figure 13





APPLICATION INFORMATION



SUPPORT CIRCUITS							
DEVICE	PACKAGE	APPLICATION	FUNCTION				
TMS3471CFS	44 pin flatpack	Timing generator	NTSC timing generator				
TMS3472ADW	20 pin flatpack with tabs	Serial driver	Driver for SRG1, SRG2, SRG3, and TRG				
TMS3473BDW	20 pin small outline	Parallel driver	Driver for ABG, IAG, and SAG				
TL1593CNS	16 pin small outline (EIAJ)	Sample and hold	Three-channel sample-and-hold IC				

Figure 16. Typical Application Circuit Diagram

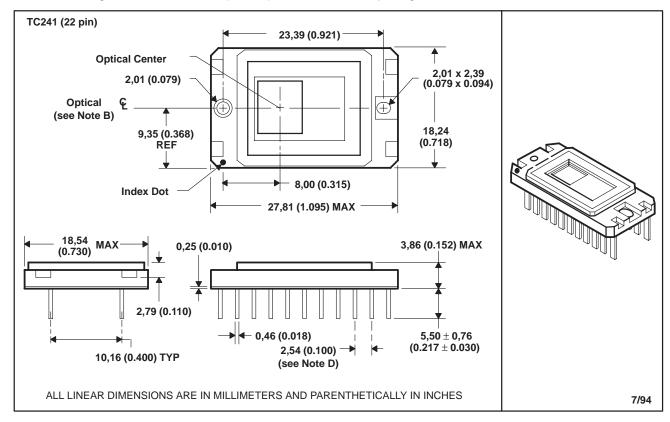
[‡]TI recommends designing AC coupled systems.



[†] Decoupling capacitors are not shown.

MECHANICAL DATA

The package for the TC241 consists of a ceramic base, a glass window, and a 22-lead frame. The glass window is sealed to the package by an epoxy adhesive. The package leads are configured in a dual in-line organization and fit into mounting holes with 2.54 mm (0.10 in) center-to-center spacings.



NOTES: A. Single dimensions are nominal.

- B. The center of the package and the center of the image area are not coincident.
- C. The distance from the top of the glass to the image-sensor surface is typically 1,46 mm (0.057 in). The glass is 0,95 ±0,08 mm thick and has an index of refraction of 1.53.
- D. Each pin centerline is located within 0,25 mm (0.010 in) of its true longitudinal position.

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